Code comparison: Problem 1

J. Sheil, O. O. Versolato, H. A. Scott, S. Langer, H. Frank and V. Bakshi



ADVANCED RESEARCH CENTER FOR NANOLITHOGRAPHY





Atomic kinetics of tin plasmas

Problem 1

This problem explores the atomic kinetics of tin under conditions relevant for EUV production.

Participants were asked to compute the charge state distribution, absorptivity, emissivity, **spectral purity**, internal energy density and radiative power losses for cases shown below:

| ID | 1 | 2 | 3 | 4 | 5 | 6 | 7 | | |
|------|--|----|----|----|------------------|------------|------------|-------------|------------|
| Te | 10 | 15 | 20 | 25 | 30 | 35 | 40 | | |
| Ne | 10 ¹⁹ Critical electron density for CO ₂ laser light | | | | | | t | | |
| | | | | | | | | , | |
| ID | 8 | 9 | 10 | 11 | 12 | 13 | 14 | 15 | 16 |
| Te | 20 | 25 | 30 | 35 | 40 | 45 | 50 | 55 | 60 |
| Ne | | | • | • | 10 ²⁰ | | | | |
| | | | | | | | | | |
| ID _ | 17 | 18 | 19 | 20 | 21 | 22 | 23 | 24 | 25 |
| Te | 20 | 25 | 30 | 35 | 40 | 45 | 50 | 55 | 60 |
| Ne | | | | | 10^{21} | Critical e | lectron de | nsity for N | d:YAG lase |
| | entited electron density for ridinite | | | | | | | | |

Participants

We received **10** submissions for problem 1

| Name | Institution | Code | non-LTE | LTE |
|---------------|--|------------|---------|-----|
| Akira Sasaki | National Institute for Quantum and Radiological Sciences | JATOM | | |
| Howard Scott | Lawrence Livermore National Laboratory | Cretin | x 3 | |
| Ilya Vichev | Keldysh Institute for Applied Mathematics | THERMOS | | |
| lgor Golovkin | Prism Computational Sciences | PrismSPECT | | |
| John Sheil | Advanced Research Center for Nanolithography | ATOMIC | | |
| Hilik Frank | Lawrence Livermore National Laboratory | SEMILLAC | | |

- Compare key quantities (average charge state, spectral purity, etc.) for each electron density group.
- Global comparison of internal energy density and radiative power losses.

| ID | 1 | 2 | 3 | 4 | 5 | 6 | 7 | | |
|----|------------------|----|----|----|-----------|----|----|----|----|
| Te | 10 | 15 | 20 | 25 | 30 | 35 | 40 | | |
| Ne | 10 ¹⁹ | | | | | |] | | |
| | | | | | | | | - | |
| ID | 8 | 9 | 10 | 11 | 12 | 13 | 14 | 15 | 16 |
| Te | 20 | 25 | 30 | 35 | 40 | 45 | 50 | 55 | 60 |
| Ne | | | | | 10^{20} | | | | |
| | | | | | | | | | |
| ID | 17 | 18 | 19 | 20 | 21 | 22 | 23 | 24 | 25 |
| Te | 20 | 25 | 30 | 35 | 40 | 45 | 50 | 55 | 60 |
| Ne | | | | | 10^{21} | | | | |

$$n_e = 10^{19} \text{ cm}^{-3}$$

$n_e = 10^{19}$ cm⁻³: Mean charge state



$n_e = 10^{19} \text{ cm}^{-3}$: Ion fraction



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$$n_e = 10^{20} \text{ cm}^{-3}$$

$n_e = 10^{20}$ cm⁻³: Mean charge state



$n_e = 10^{20}$ cm⁻³: Ion fraction



$n_e = 10^{20}$ cm⁻³: Ion fraction











$$n_e = 10^{21} \text{ cm}^{-3}$$

$n_e = 10^{21}$ cm⁻³: Mean charge state





pectral purity =
$$\frac{\int_{13.365}^{13.635} \eta_{\lambda} d\lambda}{\int_{5}^{20} \eta_{\lambda} d\lambda}$$

$n_e = 10^{19} \text{ cm}^{-3}$: Emissivity





 $n_e = 10^{21} \text{ cm}^{-3}$: Emissivity



Spectral purity: $n_e = 10^{19}$, 10^{20} & 10^{21} cm⁻³



 $T_e(eV)$

 Spectral purity decreases as you move to higher densities and higher temperatures

Radiative power losses: 10¹⁹, 10²⁰ & 10²¹ cm⁻³



Radiative Power Losses (RPL)

Total contribution from:

- bound-bound
- bound-free (recombin.) and
- free-free transitions (bremsstr.)

Good agreement between codes for all three electron density sets.

Internal energy density: 10¹⁹, 10²⁰ & 10²¹ cm⁻³



Conclusion

- Best agreement between mean charge values at low T_e.
- LTE submissions predict highest spectral purity for $\overline{Z}\approx 12.$ Greater spread in \overline{Z} for the non-LTE submissions.
- Spectral purity decreases with an increase in density (and temperature).
- Good agreement between codes for the radiative power losses and internal energy densities.